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# Study of Cr<sub>5</sub>Si<sub>3</sub> Electrodes on Langasite Surface Acoustic Wave **Resonators for High Temperature Sensing**

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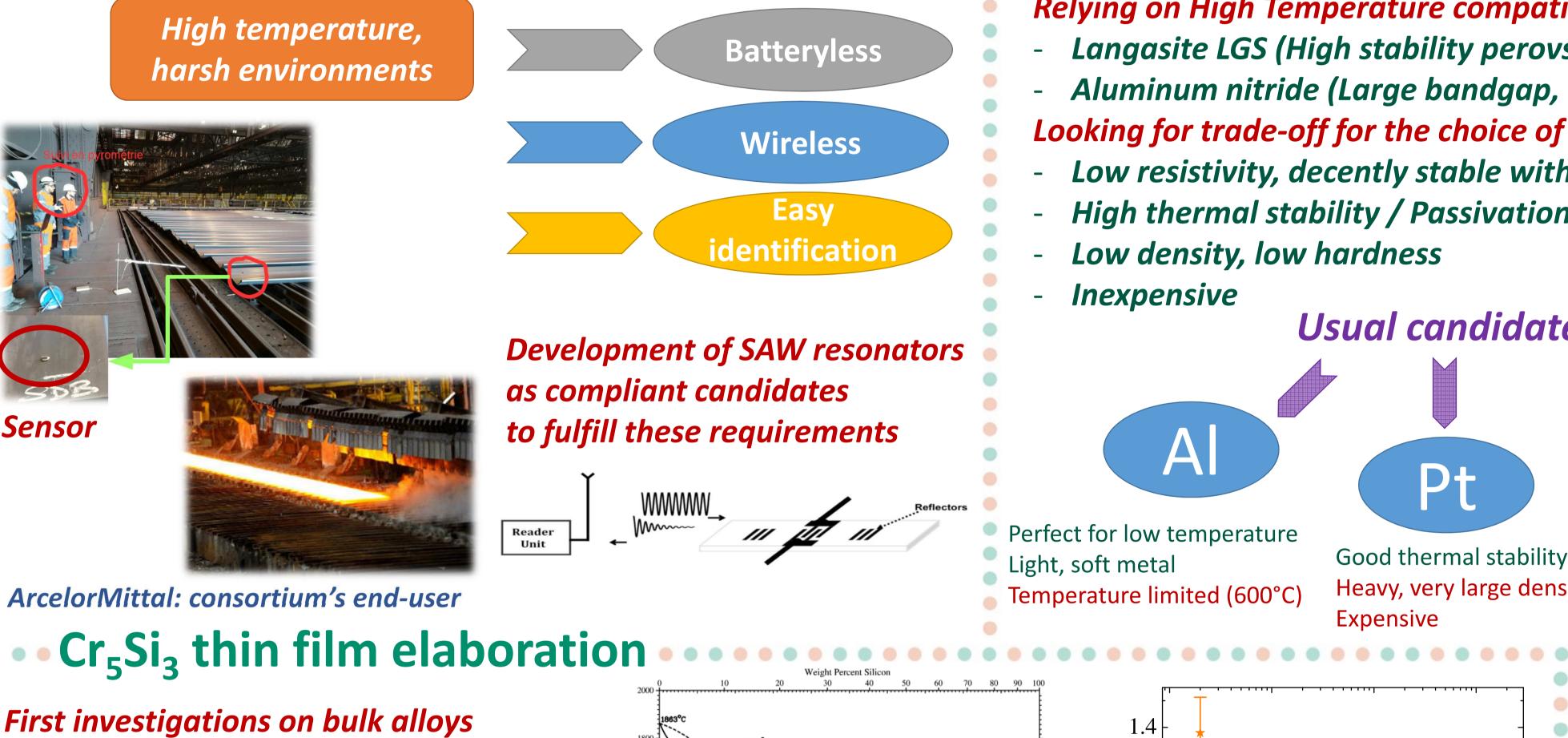
## Abstract

Sensor

Many piezoelectric materials are viewed as potential candidates for high temperature SAW applications, including langasite (LGS) and AIN. Only a few metals or alloys can withstand such temperatures, among them platinum and iridium based alloys or nanocomposites. These materials cannot be considered when high quality factors are required, due to their higher resistivity and density. The (Cr, V)-Si system was previously studied, but has never been proposed as a solution for SAW electrodes, in spite of its high thermal stability, lower density (about 6 g/cm<sup>3</sup>) and decent resistivity. This study focuses on the development of Cr<sub>5</sub>Si<sub>3</sub> alloy deposition for its use in LGSbased resonators, aiming at wireless applications.



## **Context for High Temperature Sensing**



## **Reaching trade-offs for IDT electrodes**

- Relying on High Temperature compatible piezoelectric substrates
- Langasite LGS (High stability perovskite, parabolic temperature behavior)
- Aluminum nitride (Large bandgap, high resistivity semiconductor, linear TCF) Looking for trade-off for the choice of IDT electrodes
- Low resistivity, decently stable with temperature
- High thermal stability / Passivation

Usual candidates

10

80

DRX results for  $Cr_5 Si_3$  on LGS

Temperature (°C)

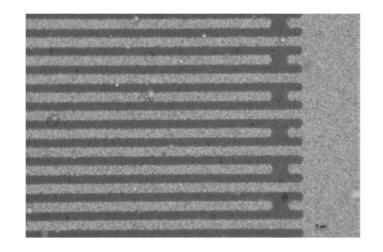
100

100

-LGS

Heavy, very large density

Medium thermal stability Large density



**Typical Aluminum IDTs Other candidates to explore: Cr-Si alloys** 

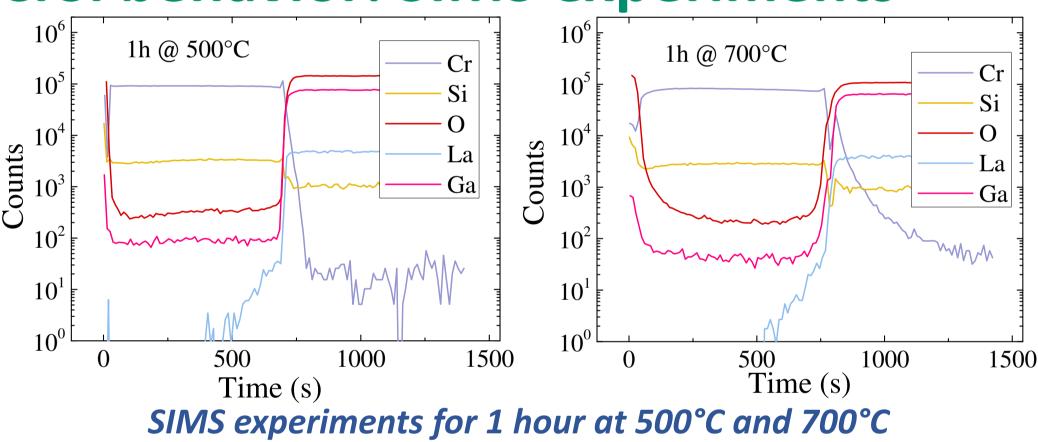
Lower density than most metals / semi-metal alloys More resistive than Pt...

...But more steady with temperature than Al Might be prone to diffusion...

...But expected to have good thermal stability

Trade-off to be investigated

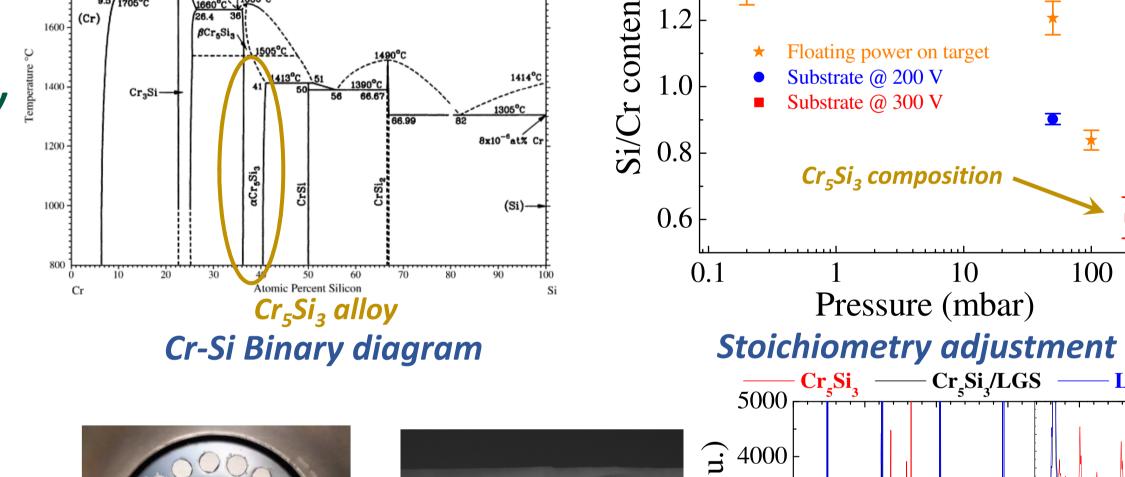




Alloys prepared in electric arc furnace Samples followed by Thermogravimetry

Cr<sub>5</sub>Si<sub>3</sub> selected as trade-off between low density and high temperature stability

Investigated system: Cr-Si



## Investigation of Cr<sub>5</sub>Si<sub>3</sub> for thin films

- Prepared by DC sputtering from Cr-Si target
- **Optimization of parameters:** 
  - Power on target
  - Floating / Set potentials on substrate
  - Chamber pressure...

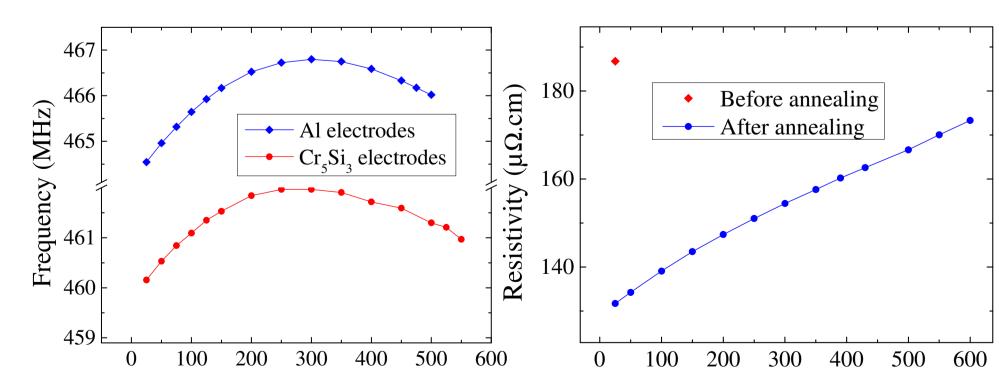




## • High Temperature SAW characterizations

### **Resonator design for first HT experiments**

- Synchronous design
- Wavelengths between 5 and 16 µm
- Aperture =  $40 \cdot \lambda$ , 100 pairs, 2 x 200 reflectors
- Electrodes choice: Cr<sub>5</sub>Si<sub>3</sub>, 200 nm



3000

Su 2000

1000

### SIMS experiments after 1 hour

- Diffusion into LGS is very limited, up to 600°C
- Slight surface oxidation

### SIMS experiments after 6 hours

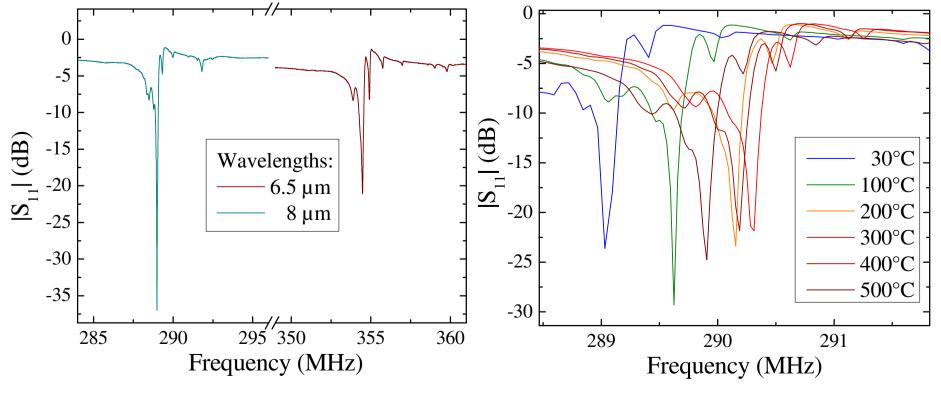
- No further diffusion into LGS
- Oxidation layer is strongly slowed down
- Good potential for light, stable electrodes up to 600°C

## **Conclusion and perspectives**

## **Exploration of Cr<sub>5</sub>Si<sub>3</sub> for SAW resonator electrodes**

- Approach: reaching a good trade-off between temperature range, low resistivity, low density, thermal stability...
- Cr<sub>5</sub>Si<sub>3</sub> shows good thermal stability up to 600°C
- Resistivity remains high, but rather steady with temperature

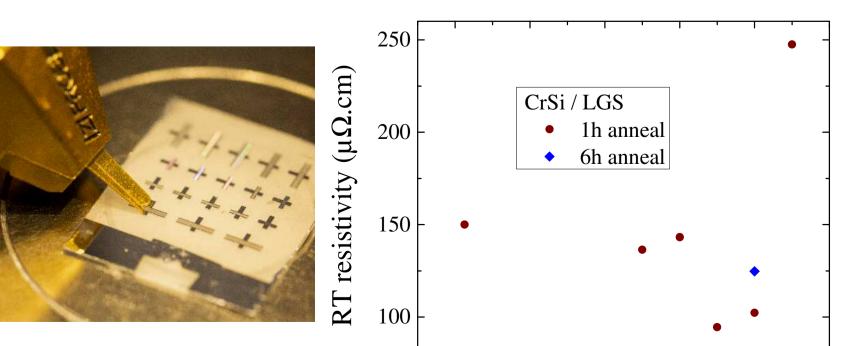
#### *Future strategies for the improvement of* Cr<sub>5</sub>Si<sub>3</sub> *electrodes* Initial anneal of electrodes, for better thermal stability



**Room Temperature and High Temperature behaviors** of LGS resonators with Cr<sub>5</sub>Si<sub>3</sub> electrodes

- *Measurements up to 550°C achieved with Cr<sub>5</sub>Si<sub>3</sub> electrodes*
- Higher resistivity than Pt, but reasonable steadyness with temperature
- 1-hour and 6-hour long anneals at 600°C exhibit comparatively lower resistivities: *importance of initial anneal of electrodes*

Temperature (°C) Frequency behavior of LGS-based Resistivity monitoring resonators: Cr<sub>5</sub>Si<sub>3</sub> vs Al electrodes of Cr<sub>5</sub>Si<sub>3</sub> IDT electrodes



**RF** characterizations

600 800 Anneal temperature (°C) Van der Pauw Resistivity on thin films of Cr<sub>5</sub>Si<sub>3</sub>

- Integration of a passivation layer
- Study of Cr<sub>5</sub>Si<sub>3</sub> with substrates less prone to interdiffusion (AIN / Sapphire...)
- **Extension to Cr-V-Si ternary alloys**

Future work on integration of Cr<sub>5</sub>Si<sub>3</sub> electrodes

- **Optimization of LGS-based and AIN-based resonators** equipped with Cr<sub>5</sub>Si<sub>3</sub> electrodes
- *Further work on* Cr<sub>5</sub>Si<sub>3</sub> aging behavior

**Other study on AIN / Sapphire optimization for wireless HT SAW** sensors (IUS 2018 Poster)

**Optimization of Al/AlN/Sapphire Acoustic Wave Sensors** for High Temperature Wireless Applications

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